

<b>INFORMATION DISCLOSURE STATEMENT</b>		Atty Docket: Serial No.: Applicant: Filing Date: Group:	02GR128554494 Not Yet Assigned BOUCHE ET AL. Herewith
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**U.S. PATENT DOCUMENTS**

Examiner Initials		Document Number	Date	Name	Class	Sub Class	Filing Date
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						

**FOREIGN PATENT DOCUMENTS**

		Document Number	Date	Country	Class	Sub Class	Translation
<i>cle</i>	AK	0907211	4/7/99	EP	H01L35	22	
	AL	0129529	4/26/01	WO	H01L21	302	
<i>cle</i>	AM	1096259	5/2/01	EP	G01P15	08	
	AN						

**OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)**

<i>cle</i>	AO	Xiao et al., Silicon/Glass Wafer-to-Wafer Bonding with Ti/Ni Intermediate Bonding, Sensors and Actuators A, Elsevier Sequoia S.A., Lausanne, CH, Vol. 71, No. 1-2, November 1, 1998, Pages 123-126, XP004140083
<i>cle</i>	AP	Dehé et al., III-V Compound Semiconductor Micromachined Actuators for Long Resonator Tunable Fabry - Pérot Detectors, Sensors and Actuators A, Elsevier Sequoia S.A., Lausanne, CH, Vol. 68, No. 1-3, June 15, 1998, Pages 365-371, XP004139861
	AQ	

EXAMINER: <i>LC</i>	DATE CONSIDERED: <i>4/28/01</i>
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.